

Day : Tuesday  
Date: 3/30/2004

Time: 14:24:47

**PALM INTRANET****Inventor Name Search Result**

for SN10/025, 907

Your Search was:

Last Name = JUNG

First Name = YUN-HO

Application#	Patent#	Status	Date Filed	Title	Inventor Name 20
10705891	Not Issued	020 1752	11/13/2003 355/18	MASK FOR LASER IRRADIATION AND APPARATUS FOR LASER CRYSTALLIZATION USING THE SAME	JUNG, YUN-HO JFW unassigned
10704749	Not Issued	020 1752	11/12/2003 355/18	MASK FOR LASER IRRADIATION, METHOD OF MANUFACTURING THE SAME, AND APPARATUS FOR LASER CRYSTALLIZATION USING THE SAME	JUNG, YUN-HO JFW
10454679	Not Issued	071 2818 Renée Berry	06/05/2003 438/778	MASK FOR SEQUENTIAL LATERAL SOLIDIFICATION AND CRYSTALLIZATION METHOD USING THEREOF	JUNG, YUN-HO JFW
10211570 20020185059	Not Issued	041 1765	08/05/2002 117/200	LASER ANNEALING APPARATUS	JUNG, YUN-HO JFW
10196415	6706545	150 116/01	07/17/2002	METHOD OF FABRICATING A LIQUID CRYSTAL DISPLAY	JUNG, YUN-HO NOT JFW
10163419	Not Issued	041 2818	06/07/2002 438/22	SILICON CRYSTALLIZATION METHOD	JUNG, YUN-HO JFW
10157201 Note: Allow - No	Not Issued	093 1765	05/30/2002 117/33	SILICON CRYSTALLIZATION METHOD	JUNG, YUN-HO JFW - no amendment
10157199	Not Issued	041 1762	05/30/2002 427/596 Eric Fuller	AMORPHOUS SILICON DEPOSITION FOR SEQUENTIAL LATERAL SOLIDIFICATION	JUNG, YUN-HO JFW
10151880 Not Allow - unallowed	Not Issued	092 1765	05/22/2002 117/4	METHOD OF CRYSTALLIZING AMORPHOUS SILICON USING A MASK	JUNG, YUN-HO JFW
10025907	Not Issued	071	12/26/2001	APPARATUS AND METHOD OF CRYSTALLIZING AMORPHOUS SILICON	JUNG, YUN-HO

<u>09697510</u>	<u>6514339</u>	150	10/27/2000	LASER ANNEALING APPARATUS	JUNG, YUN-HO
<u>09697300</u>	<u>6521473</u>	150	10/27/2000	METHOD OF FABRICATING A LIQUID CRYSTAL DISPLAY	JUNG, YUN-HO
<u>09605409</u>	<u>6316338</u>	150	06/28/2000	LASER ANNEALING METHOD	JUNG, YUN-HO
<u>09603883</u>	<u>6346462</u>	150	06/26/2000	METHOD OF FABRICATING A THIN FILM TRANSISTOR	JUNG, YUN-HO
<u>09410093</u>	<u>6335509</u>	150	10/01/1999	LASER ANNEALING APPARATUS	JUNG , YUN-HO
<u>09311702</u>	<u>6177301</u>	150	05/13/1999	METHOD OF FABRICATING THIN FILM TRANSISTORS FOR A LIQUID CRYSTAL DISPLAY	JUNG , YUN-HO
<u>09311700</u>	<u>6326286</u>	150	05/13/1999	METHOD FOR CRYSTALLIZING AMORPHOUS SILICON LAYER	JUNG , YUN-HO
<u>09212709</u>	<u>6537863</u>	150	12/16/1998	LASER BEAM SCANNING METHOD	JUNG , YUN-HO
<u>09210081</u>	<u>6323457</u>	150	12/11/1998	LASER ANNEALING APPARATUS	JUNG , YUN-HO
<u>09143505</u>	<u>6536237</u>	150	08/28/1998	LASER ANNEALING SYSTEM	JUNG , YUN-HO

Inventor Search Completed: No Records to Display.

<b>Search Another: Inventor</b>	<b>Last Name</b>	<b>First Name</b>
	<input type="text" value="jung"/>	<input type="text" value="yun-ho"/>
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	L #	Hits	Search Text	DBs	Time Stamp
1	L1	21	(( "6706545" ) or ("6514339" ) or ("6521473" ) or ("6316338" ) or ("6346462" ) or ("6335509" ) or ("6177301" ) or ("6326286" ) or ("6537863" ) or ("6323457" ) or ("6536237" )) .PN.	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB	2004/03/3 0 15:07

goes w/ inventor Name search  
for 10/025, 907

	L #	Hits	Search Text	DBs	Time Stamp
1	L1	21	(( "6706545" ) or ("6514339" ) or ("6521473" ) or ("6316338" ) or ("6346462" ) or ("6335509" ) or ("6177301" ) or ("6326286" ) or ("6537863" ) or ("6323457" ) or ("6536237" )).PN.	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB	2004/03/3 0 15:08
2	L2	516	(( (427/554,555) or (117/7-10) or (438/487,798,799)).CC LS.) and (laser light photon) adj (beam ray stream)) and (( (427/554,555) or (117/7-10) or (438/487,798,799)).CC LS.) and (".alpha." amorphous) adj (silicon Si) "a-Si"))	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB	2004/03/3 0 15:28
3	L3	37957 5	(sequential adj lateral adj solidification) SLS.u/c.	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB	2004/03/3 0 15:29
4	L4	17	2 and 3	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB	2004/03/3 0 15:29

EAST Search - update  
for 10/025, 2007

	L #	Hits	Search Text	DBs	Time Stamp
5	L5	11040	3 and (laser (light photon) adj (beam ray stream))	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM _TDB	2004/03/3 0 15:30
6	L6	676	3 and (".alpha." amorphous) adj (silicon Si) "a-Si")	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM _TDB	2004/03/3 0 15:30
7	L7	5153	(laser (light photon) adj (beam ray stream)) with (".alpha." amorphous) adj (silicon Si) "a-Si")	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM _TDB	2004/03/3 0 15:32
8	L8	143	5 and 6 and 7	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM _TDB	2004/03/3 0 15:32